FORM PTO 1449 (m	odified)		ATTY DOCKET NO. 00684.003542.	APPLICA	TION NO. 10/6	63,691
	DEPARTMENT OF COMMER	10117101	APPLICANT YASUHISA INAO, ET AL.	1		
LIST OF R	EFERENCES CITED BY APPL Ise several sheets if necessary	DEC 1 8 22 G	FILING DATE September 17, 2003		GROUP NAME	1756
	4	The said	U.S. PATENT DOCUMENTS	**		
'EXAMINER INITIAL	DOCUMENT NUMBER	DATE DATE	NAME	CLASS	SUBCLASS	FILING DATE
TSR	6,171,739	01/09/01	Spence et al.	430	30	
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		FO	REIGN PATENT DOCUMENTS			
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
JSR	2000-112116	04/21/00	Japan			Abstract
				·		
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	01	HER DOCUMENT(S)	(Including Author, Title, Date, Pertinent Pages, Etc.)			
TSR	"Sub-diffraction-limi Letters (1999), Vol. 7	ted patterning usi 5, No. 22, pp. 3560	ng evanescent near-field optical lithography, 0-3562.	," M.M. Al	kaisi et al., Ap	plied Physics
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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